



In re Application of:

Yasunori INOUE et al

Serial No.: **08/921,250**

Filed: **August 29, 1997**

For: **FABRICATION METHOD OF SEMICONDUCTOR DEVICE AND ABRASIVE LIQUID USED THEREIN**

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Group Art Unit: **1763**

Examiner: **Goudreau, G.**

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

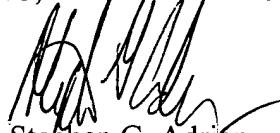
January 28, 2002

Sir:

This paper is filed to supplement the Information Disclosure Statement filed November 2, 2001. A substitute Form PTO-1449 is filed herewith which corrects the European Publication date. A copy of the cited document were previously submitted with the Information Disclosure Statement filed November 2, 2001.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,
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